IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Confirmation No.: 4333

Hideki Imai, et al. Date: December 8, 2010

Serial No.: 10/577,111 Group Art Unit: 2431

Filed: April 25, 2006 Examiner: Shin Hon Chen

For: AUTHENTICATION SYSTEM AND REMOTELY DISTRIBUTED STORAGE

SYSTEM

VIA EFS-WEB

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Submitted herewith is a copy of an Office Action issued by a patent searching authority other than the USPTO and the cited art together with a form PTO-1449 listing the same for the convenience of the Examiner.

The references JP4-245287 and SeongHan Shin, Kazukuni KOBARA, Hideki IMAI," A New Password-based Authentication Protocol", Computer Security Symposium 2003 (CSS2003), Information Processing Society of Japan, Vol.2003, No.15, 29 October, 2003, Pages 7-12, cited in the Office Action, were previously cited on a form PTO-1449 and filed with the subject patent application on April 25, 2006.

In addition, the form PTO-1449 listing the cited art that was submitted with the subject patent application on April 25, 2006 contains a typographical error in the first non-patent literature article, as shown below. The enclosed form PTO-1449 lists the article correctly. The article has already been submitted to the Patent Office.

Kazukuni KOBARA and Hideki IMAI, "Pretty-Simple Password-Authenticated Key-Exchange Protocol Proven to be Secure in the Standard Model", IEICE Transactions on Fundamentals of Electronics, Communication and Computer Sciences, Vol E85-A, No.10, 01 October 2002, pages 2229-2237 (not 22237).

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in a counterpart foreign application not more than 3 months prior to the filing of this Submission.

I respectfully request that the information submitted be considered. Credit card payment in the amount of \$180 for the required fee is being submitted via EFS-WEB.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the Patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

THIS CORRESPONDENCE IS BEING SUBMITTED ELECTRONICALLY THROUGH THE PATENT AND TRADEMARK OFFICE EFS FILING SYSTEM ON December 8, 2010.

Respectfully submitted,

Robert C. Faber

Registration No.: 24,322 OSTROLENK FABER LLP 1180 Avenue of the Americas New York, New York 10036-8403

Telephone: (212) 382-0700

RCF:JJF:ck